



Attorney Docket No. 0756-2447

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 10/084,935

Filed: March 1, 2002

For: INSULATING FILM AND METHOD  
OF PRODUCING SEMICONDUCTOR  
DEVICE

) Group Art Unit: 2815

) Examiner: Jerome Jackson, Jr.

) CERTIFICATE OF MAILING  
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Commissioner for Patents, P.O. Box 1450,  
Alexandria, VA 22313-1450, on July 28, 2008.) Adrian StampsAFTER FINAL RESPONSE

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The Official Action mailed March 28, 2008, has been received and its contents carefully noted. Filed concurrently herewith is a *Request for One Month Extension of Time*, which extends the shortened statutory period for response to July 28, 2008. Accordingly, the Applicant respectfully submits that this response is being timely filed.

The Applicant appreciates Examiner Jackson's time in conducting a telephonic interview on July 1, 2008. As described in more detail below, during the interview the Applicant's representative explained that there is insufficient basis for the assertion that the claimed halogen and carbon concentrations are inherent. The Examiner agreed to consider the Applicant's remarks following the submission of this Response.

The Applicant notes with appreciation the consideration of the Information Disclosure Statements filed on March 1, 2002; June 4, 2002; October 3, 2002; April 11, 2003; December 16, 2003; March 27, 2006; December 14, 2006; and December 17, 2007.

Claims 19-23, 25, 26 and 63-80 are pending in the present application, of which claims 19, 63, 69 and 75 are independent. For the reasons set forth in detail below, all